INFORMATION DISCLOSURE STATEMENT PTO-1449

Atty. Docket No. 971003B

Serial No. Not yet assigned

Applicants: Hideki MATSUMURA et al.

Group Art Unit: 1763 (Expected)

Filing Date: January 10, 2002

## U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
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